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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Heng-Yong Nie, et al.
Appln. No. :

International Filing Date: August 17, 2004

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Title : METHOD OF CONTROLLABLE MORPHOLOGY OF SELF-
ASSEMBLED MONOLAYERS ON SUBSTRATES

Grp./A.U. :

Examiner :

Docket No. :

Honorable Commissioner for Patents
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT BEFORE EXAMINATION

Please amend the above-referenced National Phase patent application as follows:

Amendments to the abstract begins on page 2 of this paper.

Amendments to the specification begins on page 3 of this paper.

Amendments to Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 14 of this paper.

Appendix: Abstract of the Disclosure